

**REPLY UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER 2800**

Attorney's Docket No.: 42P17764

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

*OK to enter  
2/15/07*  
In Re Patent Application of:

**Alejandro Hurtado**

Application No.: 10/769,534

Filed: January 30, 2004

For: **MOUNTING AND DICING PROCESS  
FOR WAFERS**

Examiner: **Ha, Nathan W.**

Art Unit: **2814**

Confirmation No.: **8641**

**RESPONSE TO FINAL OFFICE ACTION**

Mail Stop AF  
Commissioner for Patents  
P. O. 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the final Office Action mailed November 13, 2006, Applicant respectfully requests entry of the following amendments.